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Dated: March 29, 2005

Signature: \_\_\_\_\_

(Michael R. Hull)

Docket No.: 30205/39380  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Jong Goo Jung et al.

Application No.: 10/603,976

Confirmation No.: 3741

Filed: June 25, 2003

Art Unit: 2813

For: CMP SLURRY COMPOSITION FOR OXIDE  
FILMS AND METHODS FOR FORMING  
METAL LINE CONTACT PLUGS USING THE  
SAME

Examiner: Stephen W. Smoot

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the final office action dated January 6, 2005, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.

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